

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/620,468
Filing Date July 15, 2003
Inventor Dinesh Chopra
Assignee Micron Technology, Inc.
Group Art Unit 2822
Examiner T. Tran
Attorney's Docket No. MI22-2345
Title: Conductive Connection Forming Methods, Oxidation Reducing Methods, and Integrated
Circuits Formed Thereby

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98


In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patent reference listed on the attached Form PTO-1449. No admission is made regarding whether the submitted reference is prior art.

This Information Disclosure Statement is being filed before the mailing of a first Office Action on the merits. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Citation of this reference is respectfully requested.

Respectfully submitted,

Dated: 17 Dec 2004


James E. Lake
Reg. No. 44,854

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2345	SERIAL NO. 10/620,468			
<div style="position: relative; width: 100px; height: 100px; margin: 0 auto;"> <div style="position: absolute; top: 0; left: 0; width: 100%; height: 100%; border: 1px solid black; border-radius: 50%; text-align: center; line-height: 100px; font-size: 24px; font-weight: bold;">O I P E</div> <div style="position: absolute; bottom: 0; left: 0; width: 100%; height: 100%; border: 1px solid black; border-radius: 50%; text-align: center; line-height: 100px; font-size: 24px; font-weight: bold;">PATENT & TRADEMARK OFFICE</div> <div style="position: absolute; top: 50%; left: 50%; transform: translate(-50%, -50%); font-size: 18px; font-weight: bold;">DEC 17 2004</div> </div>				LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				
				APPLICANT Dinesh Chopra FILING DATE July 15, 2003 GROUP 2822				
U.S. PATENT DOCUMENTS								
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate		
AA	5,700,735	12/1997	Shiue et al					
AB								
AC								
AD								
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FOREIGN PATENT DOCUMENTS								
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
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